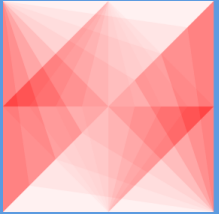




**POLITECNICO**  
MILANO 1863

DIPARTIMENTO  
DI MECCANICA



**IC**  
**LABS**

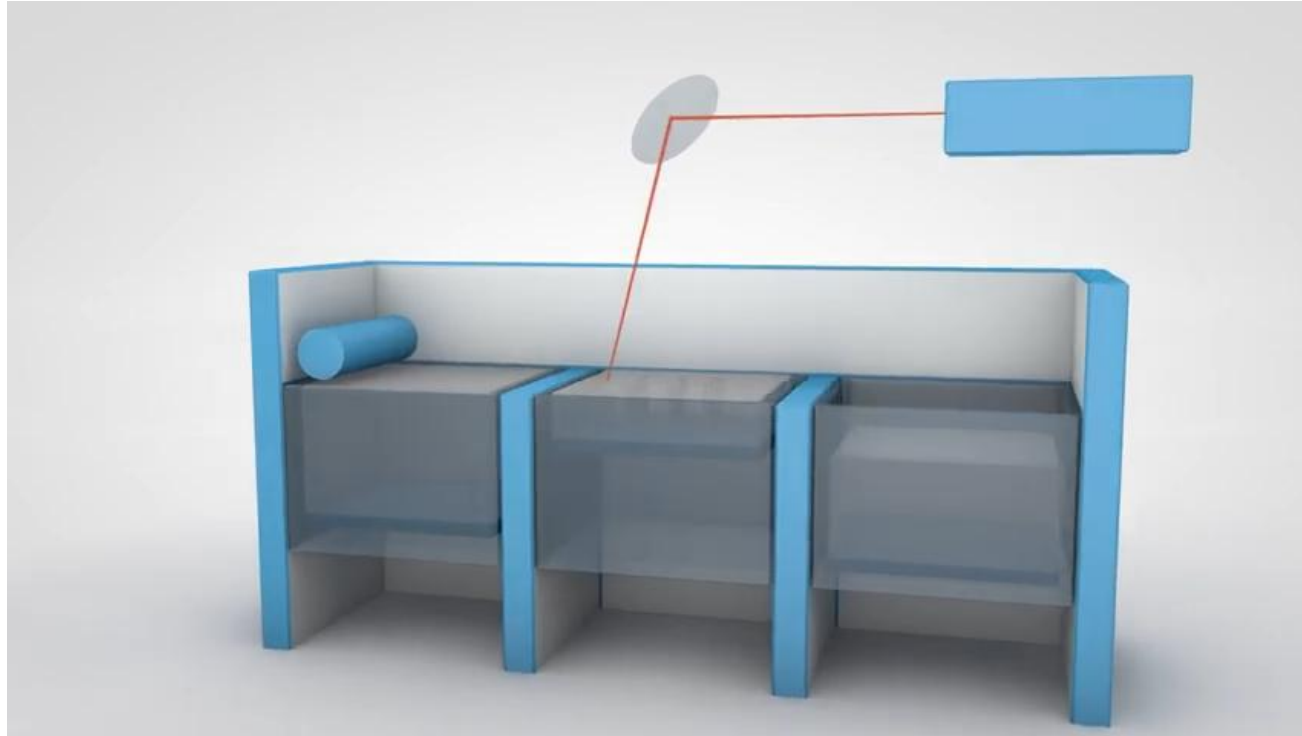
# **QDA project 2025**

***In-situ monitoring of LPBF with dual pyrometry***

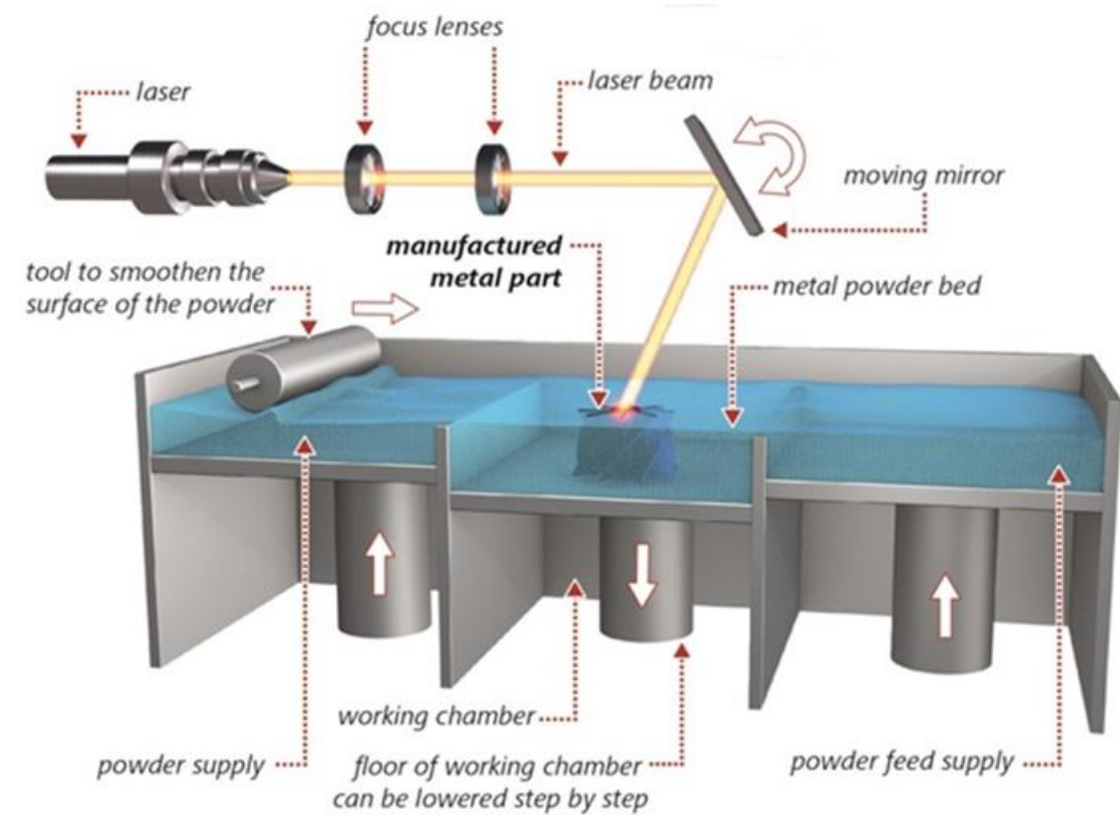


# Process monitoring for Laser Powder Bed Fusion

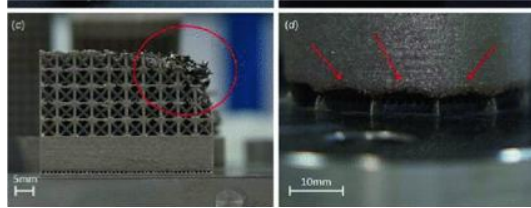
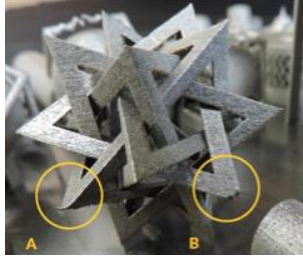
# Laser Powder Bed Fusion process



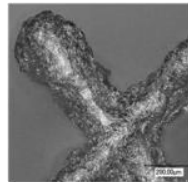
<https://www.youtube.com/watch?v=ruvRijM7f50>



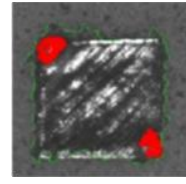
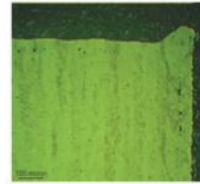
# Defects in AM



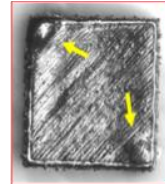
Incomplete jobs or bending



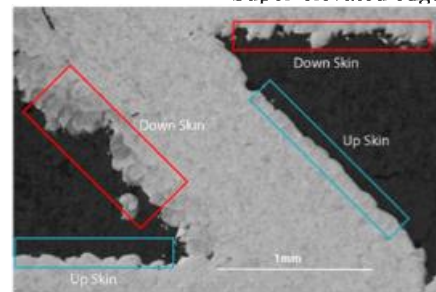
Acute corners



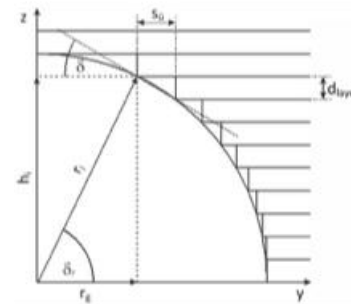
Super-elevated edge



## Micro-geometry



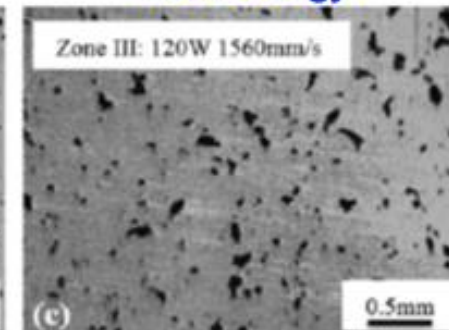
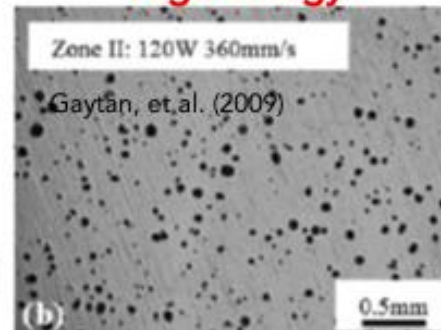
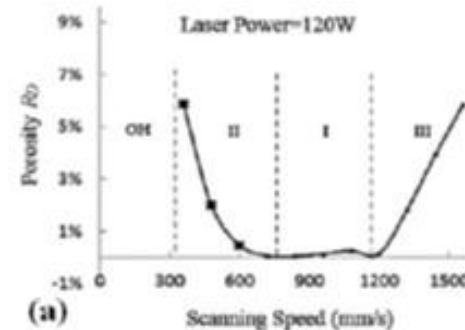
Dross formation



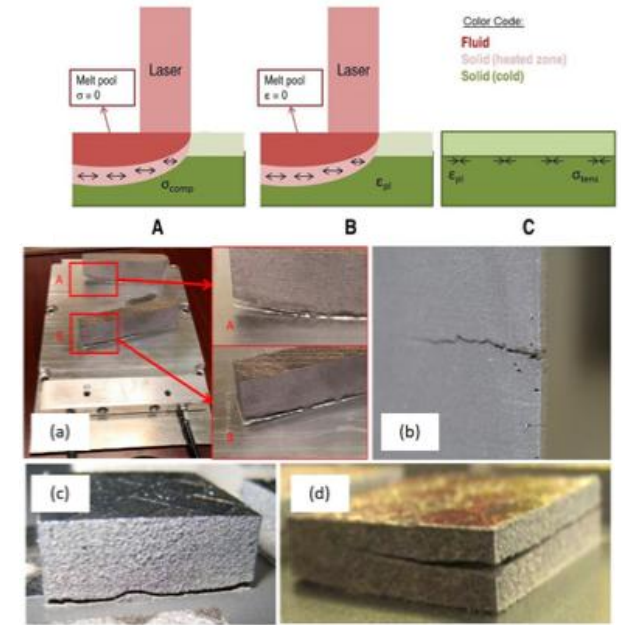
Staircase effect

High energy

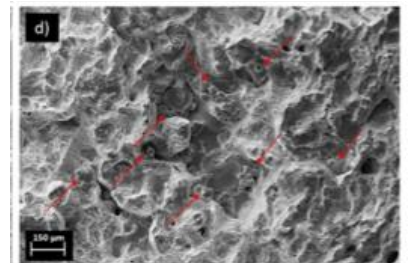
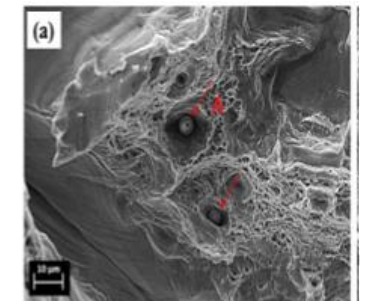
Low energy



## Residual stress, cracking delamination



## Microstructural defects and inclusions



## Volumetric errors



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«The limited stability and repeatability of the process still represent a major barrier for the industrial breakthrough of metal AM systems»

## In-situ monitoring in LPBF: the current landscape

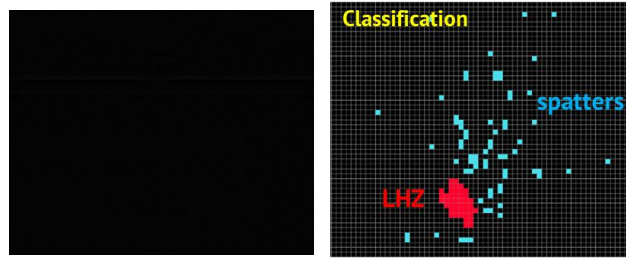
### Video imaging

Hot- cold-spot  
(geometrical and microstructure)



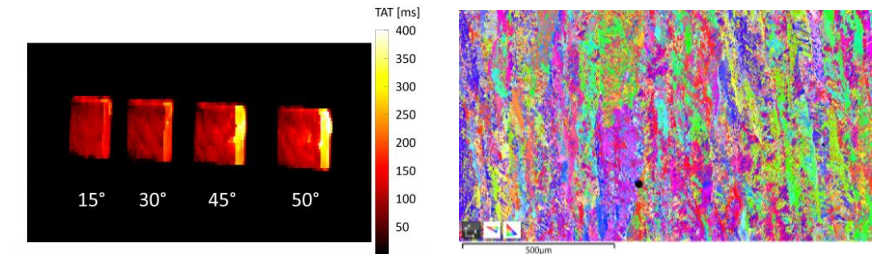
Grasso et al. 2020; Bugatti and Colosimo 2022, Yao et al. 2022

Spattering  
(porosity)



Repossini et al. 2017; Colosimo et al. 2024

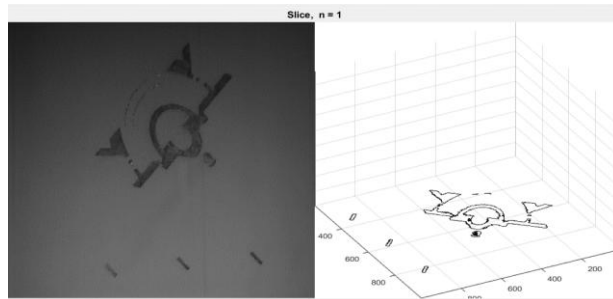
Thermal imaging  
(for roughness and microstructure)



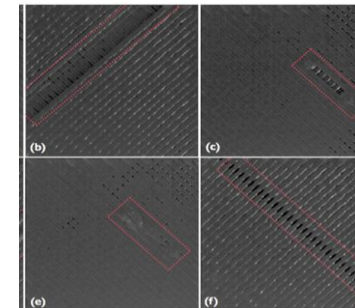
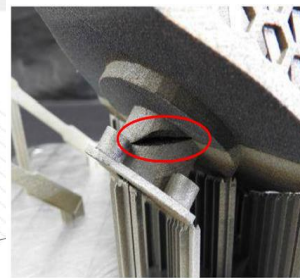
Bugatti and Colosimo 2024

with GA Tech

### Imaging

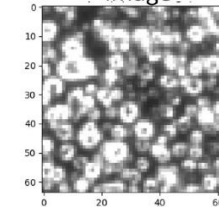


Pagani et al, 2020

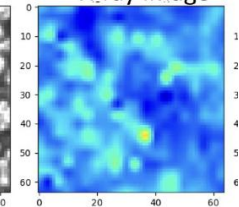


Caltanissetta et al. 2023

Input: optical  
image



Ground truth:  
X-ray image

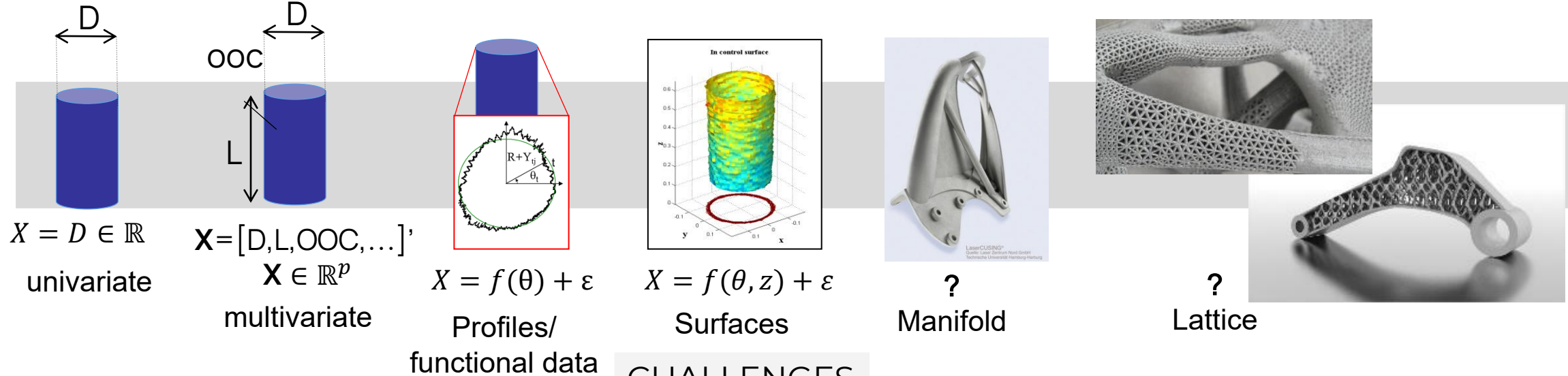


Packing density prediction (with MIT)

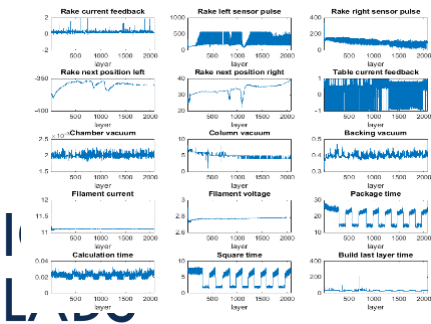
“In a sense, AM has become a manufacturing domain that is **data-rich** but **knowledge-sparse**” <https://doi.org/10.1115/DETC2019-98415>

# In-situ monitoring in LPBF: the current landscape

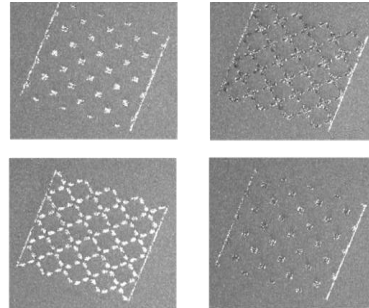
PRODUCT DATA



signals



Image



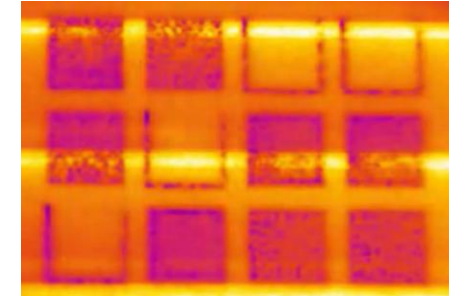
5 - 10 Gbyte

High-speed videos



5 - 10 Tbyte

IR videos

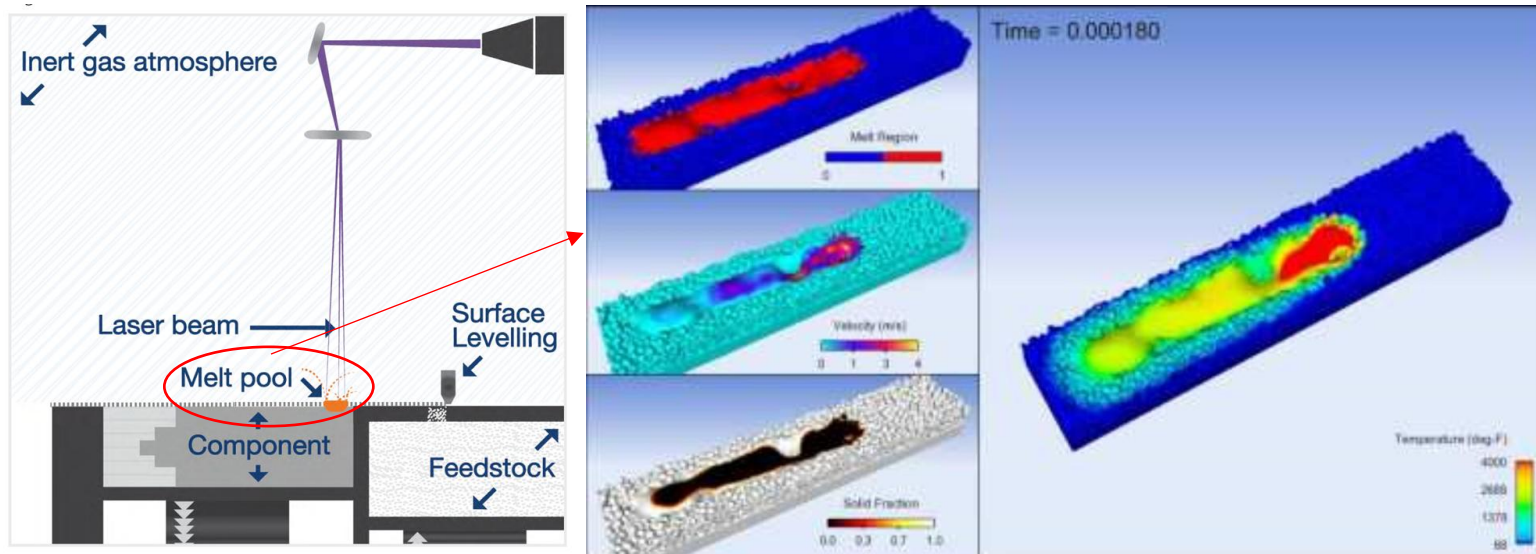


50 - 100 Tbyte

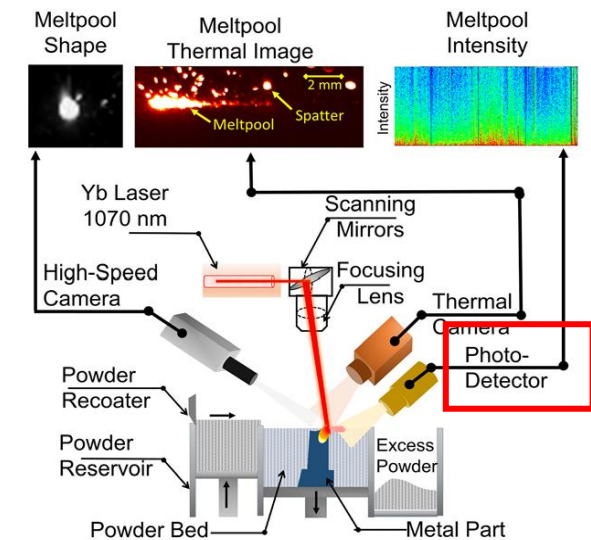
PROCESS DATA

# Temperature monitoring in Laser Powder Bed Fusion

The quality of the LPBF printed parts depends on the stability of the melt pool that is generated during melting.



## Monitoring the melt pool



<https://doi.org/10.1115/1.4040264>

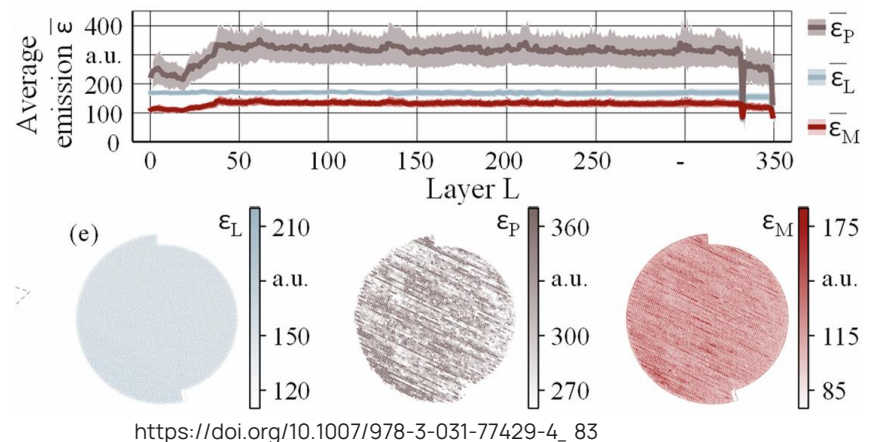
# Pyrometer for temperature monitoring in LPBF

## Dual-wavelength pyrometer:

A non-contact temperature sensor that measures emitted radiation at two wavelengths to calculate temperature.

## Output of the pyrometer data

By combining the emitted radiation of the two photodiodes, an estimate of the temperature can be calculated (see appendix slides). The output is a real-time temperature signal of the melt pool.



## How is it used in LPBF monitoring?

- **Process Quality Control:** Identifies defects like porosity or overheating.
- **Real-Time Process Adjustment:** Enables closed-loop control of laser power and scan speed.



The logo for IC LABS, featuring a square composed of many overlapping triangles in various shades of red and orange, creating a geometric, crystalline effect.

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LABS

Project description

# The equipment

- LPBF system: Aconity MIDI+
- Monitoring: On-axis dual pyrometer

---

## On-Axis Dual Pyrometer specifications

Optical arrangement	Coaxial monitoring
Sensor type	2 x fiber coupled pyrometers
Spectral range	Pyrometer 1: 1,45 - 1,7 $\mu\text{m}$ Pyrometer 2: 2,00 - 2,2 $\mu\text{m}$
Measuring range	500 - 2500 $^{\circ}\text{C}$
Measurement area	ca. $\varnothing$ 400 $\mu\text{m}$ , lateral adjustable (may vary depending on machine configuration)
Frame rate	100 kHz

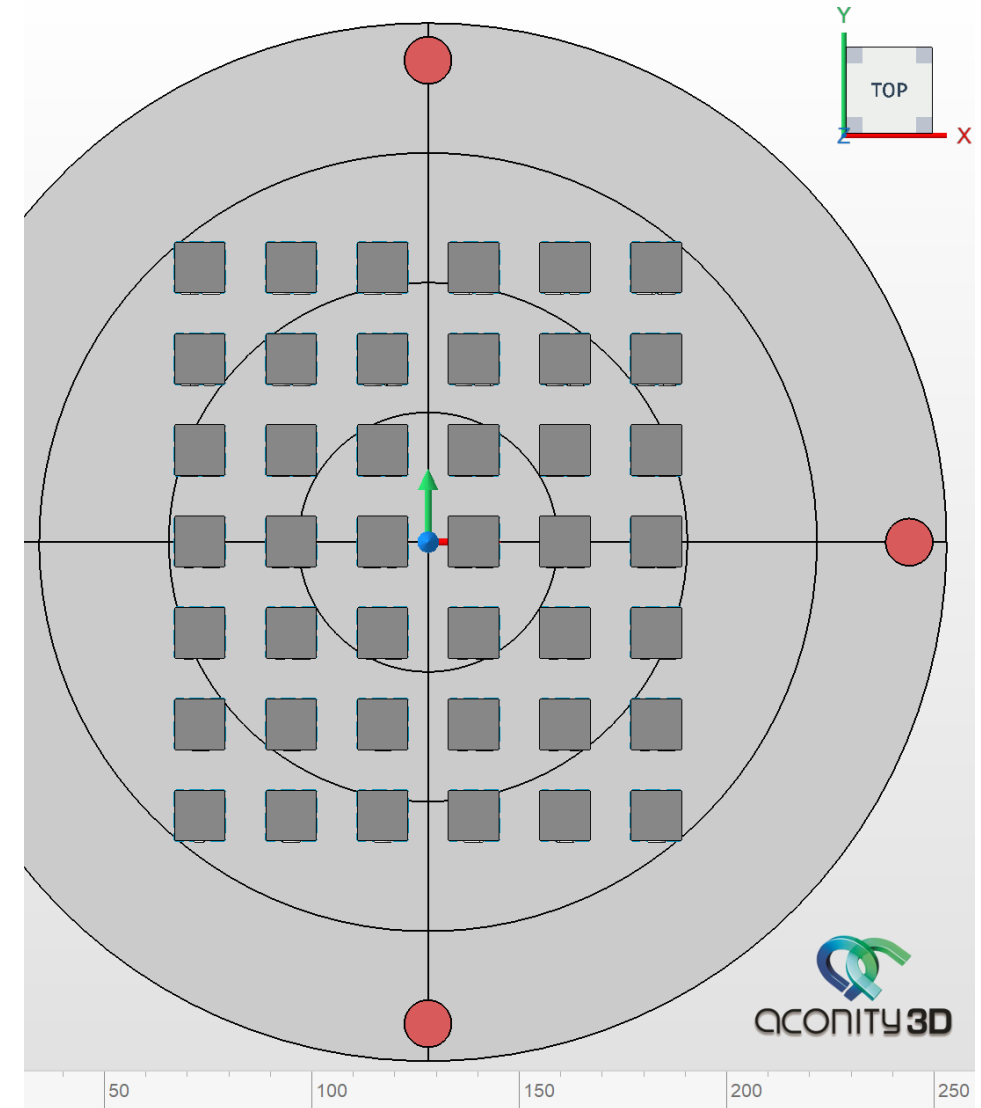
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Aconity MIDI+ with dual pyrometer

# Experimental plan

- 42 cubic samples (12x12x50mm)
- Same power and scan speed
- The pyrometer records the data over 5 consecutive layers every 100 layers.



Build platform

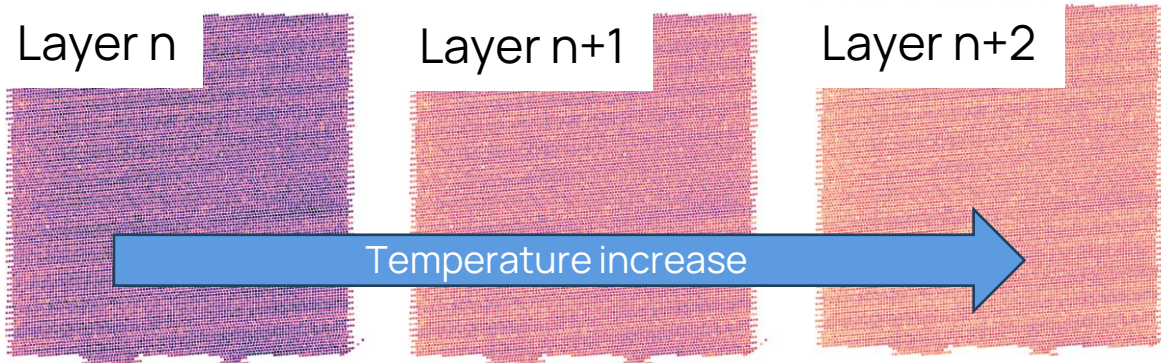


# Examples of defects

Defects include:

- Under/overheating
- Melt pool instability

Which can occur at layer level or track level.



Layer-level analysis

Low T

High T



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Large temperature gaps between adjacent lines

Isolated low/high temperature meas.

Track-level analysis



*Aim of the work:* Design one or more control charts to monitor if the printing process is stable.

# The project

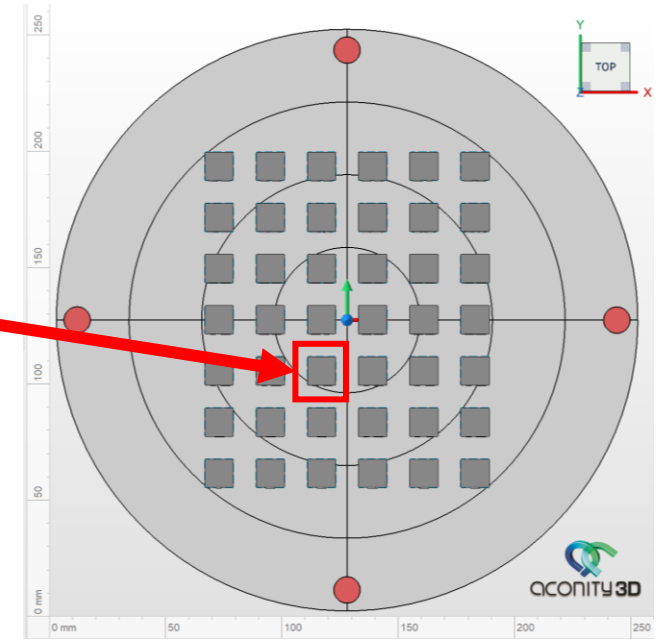
You will be given a dataset containing the measurements for one individual sample.

- **PHASE 1 (31<sup>st</sup> of March – 18<sup>th</sup> of May)**

- You will be given a set of files (one for each layer) containing the data collected when printing the first half of the sample.
- Analyze / model the data.
- Check assumptions, and design appropriate control chart(s) to monitor the process.

- **PHASE 2 (18<sup>th</sup> of May – 31<sup>st</sup> of May)**

- You will be given a new set of data containing the measurements of the second half of the same sample analyzed in Phase 1.
- Test the control charts designed in phase 1 on the new dataset.



Phase 1

- Design phase

Phase 2

- Test phase

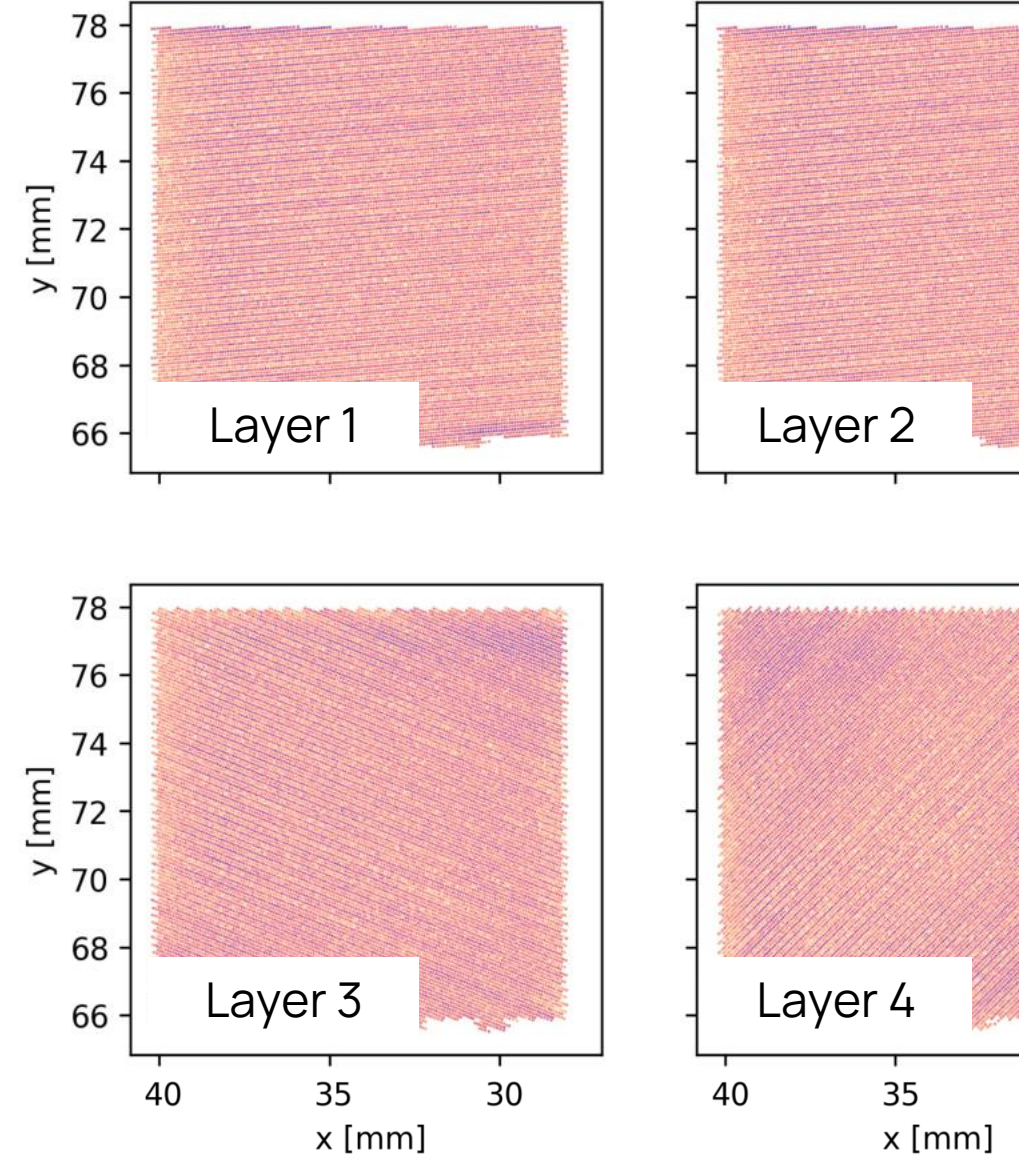
# The dataset

Each CSV file you will be given contains the following columns.

Column name	Description
t	Absolute time reading (in $\mu\text{s}$ )
x	x coordinate of the measurement (in mm)
y	y coordinate of the measurement (in mm)
z	z coordinate of the measurement (layer height, in mm)
layer_id	Layer number
sensor0	Intensity meas. from pyrometer in the 1450-1700 nm range
sensor1	Intensity meas. from pyrometer in the 2000-2200 nm range
temp	Temperature computed from the intensity meas. (in K)
track_id	ID of each individual track (from 0 to the # of tracks)
track_orient	Orientation of the scan track (0-360°, with respect to the x axis)
pos_rel	Relative position of the meas. with respect to the start of the track (in mm)
t_rel	Relative time of the meas. with respect to the start of the track (in $\mu\text{s}$ )

Low T

High T



Example of point cloud data from multiple layers.

# Team registration

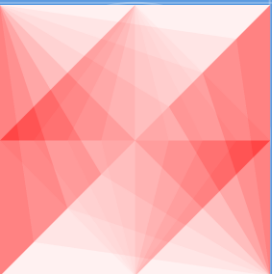
Click on this [link](#) to open the excel file. Each group must sign up with the names of the members, Polimi person code and email address.

- Create your team with up to 4 people per team (4 people recommended).
- In case your team is incomplete (less than 4 members), you can still register a team. We encourage students who don't have a team yet to contact other incomplete teams to join.
- If you can't find a team, register a 1-member team using the form and we will help you join a team.
- Teams that have less than 4 members, may be assigned additional team members.

	A	B	C	D	E	F
1	<b>QDA project registration</b>					
2	<b>Team ID</b>	<b>Member</b>	<b>Full name</b>	<b>Polimi person code</b>	<b>Email</b>	<b>Note</b>
3	Example	1	Name Surname	19999991	<a href="mailto:name1.surname@mail.polimi.it">name1.surname@mail.polimi.it</a>	
4	Example	2	Name Surname	19999992	<a href="mailto:name2.surname@mail.polimi.it">name2.surname@mail.polimi.it</a>	
5	Example	3	Name Surname	19999993	<a href="mailto:name3.surname@mail.polimi.it">name3.surname@mail.polimi.it</a>	
6	Example	4	Name Surname	19999994	<a href="mailto:name4.surname@mail.polimi.it">name4.surname@mail.polimi.it</a>	
7	1	1				
8	1	2				
9	1	3				
10	1	4				
11	2	1				
12	2	2				
13	2	3				

**Deadline for team registration:  
30<sup>th</sup> March 11:59PM**





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Thank you for the attention

The logo for IC LABS, featuring a square composed of many overlapping triangles in various shades of red and orange, creating a geometric, crystalline effect.

**IC  
LABS**

## Appendix 1

## Dual pyrometer

Each pyrometer captures the **intensity of the radiation from the melt pool** ( $I_1, I_2$ ) and its surrounding area (approx. Ø 400 µm) at high acquisition rate (100 kHz).

Assuming that the emissivity of the radiator is constant for the two wavelengths ( $\varepsilon_1 = \varepsilon_2$ ), the temperature  $T$  can be determined from the ratio of the two intensities measured at different wavelengths.

$$I_1 = \frac{\varepsilon_1 K_1}{\lambda_1^5 e^{\frac{h c_0}{k \lambda_1 T}}} \quad I_2 = \frac{\varepsilon_2 K_2}{\lambda_2^5 e^{\frac{h c_0}{k \lambda_2 T}}}$$

$$\frac{I_1}{I_2} = \frac{\varepsilon_1 K_1 \lambda_2^5 e^{\frac{h c_0}{k \lambda_2 T}}}{\varepsilon_2 K_2 \lambda_1^5 e^{\frac{h c_0}{k \lambda_1 T}}}$$

$$\Rightarrow T = \left( \frac{1}{\lambda_2} - \frac{1}{\lambda_1} \right) \frac{h c_0}{k \ln \left( \frac{I_1 \lambda_1^5}{I_2 \lambda_2^5} \frac{K_2}{K_1} \right)}$$